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CONFIRMATION NO. 2616

<b>SERIAL NUMBER</b> 10/822,556	<b>FILING or 371(c) DATE</b> 04/12/2004 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1795	<b>ATTORNEY DOCKET NO.</b> S1459.70088US00		
<b>APPLICANTS</b> Masashi Enomoto, Tokyo, JAPAN; Toshio Honda, Kanagawa, JAPAN; <b>** CONTINUING DATA *****</b> <b>** FOREIGN APPLICATIONS *****</b> JAPAN JP2003-108076 04/11/2003 JAPAN JP2003-018075 04/11/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 06/23/2004						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/ASHA J HALL/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance AH Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 9	<b>TOTAL CLAIMS</b> 26	<b>INDEPENDENT CLAIMS</b> 12
<b>ADDRESS</b> Randy J. Pritzker Wolf, Greenfield & Sacks, P.C. 600 Atlantic Avenue Boston, MA 02210 UNITED STATES						
<b>TITLE</b> Photoelectric conversion device fabrication method, photoelectric conversion device, electronic apparatus manufacturing method, electronic apparatus, metal film formation method and layer structure, and semiconductor fine particle layer and layer structure						
<b>FILING FEE RECEIVED</b> 1782	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			